Docket No.: 67161-106

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Customer Number: 20277

Yasuhiro SATO

Confirmation Number:

Serial No.:

Group Art Unit:

Filed: September 23, 2003

Examiner:

For:

REGISTRATION CORRECTION AMOUNT CALCULATING APPARATUS FOR CALCULATING

AMOUNT OF CORRECTION FOR REGISTRATION INSPECTION APPARATUS FROM

REGISTRATION INSPECTION DATA OF PATTERN FORMED ON WAFER

CLAIM OF PRIORITY AND TRANSMITTAL OF CERTIFIED PRIORITY DOCUMENT

Mail Stop CPD Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 35 U.S.C. 119, Applicant hereby claim the priority of:

Japanese Patent Application No. 2003-100606(P), filed on April 3, 2003.

cited in the Declaration of the present application. A certified copy is submitted herewith.

Respectfully submitted,

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日本国特許庁

JAPAN PATENT OFFICE

McDermott, Will & Emery

別紙添付の書類に記載されている事項は下記の出願書類に記載されて いる事項と同一であることを証明する。

This is to certify that the annexed is a true copy of the following application as filed with this Office

出願年月日

Date of Application: 2003年 4月

出 願 番 号

Application Number:

特願2003-100606

3 日

ST.10/C]:

[JP2003-100606]

出 願 人 Applicant(s):

株式会社ルネサステクノロジ

2003年 6月10日

特許庁長官 Commissioner, Japan Patent Office

